



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

February 13, 2025

IGI Report Number

Description

Shape and Cutting Style

Measurements

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

LG683541335

Report verification at [igi.org](https://www.igi.org)

PROPORTIONS

Medium

68%

13.5%

50.5%

67.3%

Long

Sample Image Used

CLARITY CHARACTERISTICS

KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF VS ¹⁻² VS ¹⁻² SI ¹⁻² I ¹⁻³

Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

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IGI Report No LG683541335

EMERALD CUT

6.91 X 4.83 X 3.25 MM

1.07 CARAT

D

VVS 2

EXCELLENT

EXCELLENT

NONE

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Color Grade	65%	
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Graile		
Culet		
Polish		
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